

JPW



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In response to application of

Docket No: Q77403

Kenji SERA, et al.

Appln. No.: 10/657,196

Group Art Unit: 2813

Confirmation No.: 1621

Examiner: Thanhha S. PHAM

Filed: September 9, 2003

For: THIN FILM SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD

AMENDMENT UNDER 37 C.F.R. § 1.111

MAIL STOP AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated March 22, 2006, please amend the above-identified application as follows on the accompanying pages.

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